

Notice of References Cited	Application/Control No. 10/629,688	Applicant(s)/Patent Under Reexamination LIN, JACK	
	Examiner Jacob Y. Choi	Art Unit 2875	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,097,400	03-1992	Cvek, Sava	362/287
	B	US-6,619,828	09-2003	Montet et al.	362/539
	C	US-5,105,345	04-1992	Katoh et al.	362/256
	D	US-6,059,426	05-2000	Lavy, Danny	362/264
	E	US-6,238,072	05-2001	Eto, Toyozo	362/539
	F	US-6,783,263	08-2004	Cronk, Paul Andrew	362/347
	G	US-6,126,300	10-2000	Lee, Dominic	362/352
	H	US-5,249,111	09-1993	Richardson, Brian E.	362/302
	I	US-5,249,110	09-1993	Russello et al.	362/294
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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